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CENTRAL FAX CENTER****JUL 28 2006****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****Applicant(s):** William G. America et al.**Examiner:** Jack S. J. Chen**Serial No:** 10/674,646**Art Unit:** 2813**Filed:** September 30, 2003**Docket:** YOR920030320US1 (16868)**For:** PLASMA SURFACE MODIFICATION  
AND PASSIVATION OF ORGANO-  
SILICATE GLASS FILMS FOR  
IMPROVED HARDMASK ADHESION  
AND OPTIMAL RIE PROCESSING**Dated:** July 28, 2006**Confirmation No.** 4797Mail Stop Amendment  
Commissioner for Patents  
Alexandria, VA 22313-1450**RESPONSE UNDER 37 C.F.R. § 1.111 AND  
CORRECTED §131 DECLARATION**

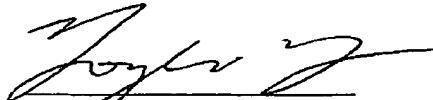
Sir:

In response to the Office Action dated June 29, 2006, Applicants are hereby submitting a corrected §131 declaration with the following remarks for entry in the above-identified case.

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**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this document is being filed in the United States Patent and Trademark Office on the date shown below via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 at United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

**Dated:** July 28, 2006  
Yongzhi Yang

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